

Day : Wednesday

Date: 3/30/2005

Time: 10:25:46

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Inventor Name Search Result

Your Search was:

Last Name = NISHIDA

First Name = SHOJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10259285	Not Issued	071	09/30/2002	CRYSTAL GROWTH PROCESS, SEMICONDUCTOR DEVICE, AND ITS PRODUCTION PROCESS	NISHIDA, SHOJI
10338847	Not Issued	161	01/09/2003	PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE	NISHIDA, SHOJI
10364517	Not Issued	041	02/12/2003	APPARATUS FOR PRODUCING SEMICONDUCTOR THIN FILMS ON MOVING SUBSTRATES	NISHIDA, SHOJI
10379457	6869863	150	03/03/2003	FABRICATION PROCESS OF SOLAR CELL	NISHIDA, SHOJI
10385457	Not Issued	041	03/12/2003	LIQUID-PHASE GROWTH APPARATUS AND METHOD	NISHIDA, SHOJI
10397310	Not Issued	092	03/27/2003	LIQUID-PHASE GROWTH METHOD AND LIQUID-PHASE GROWTH APPARATUS	NISHIDA, SHOJI
10400636	6872248	150	03/28/2003	LIQUID-PHASE GROWTH PROCESS AND LIQUID-PHASE GROWTH APPARATUS	NISHIDA, SHOJI
10402214	Not Issued	041	03/31/2003	PROCESS FOR PRODUCING SINGLE CRYSTAL SILICON WAFERS	NISHIDA, SHOJI
10505979	Not Issued	020	08/27/2004	PROCESS OF PRODUCING MULTICRYSTALLINE SILICON SUBSTRATE AND SOLAR CELL	NISHIDA, SHOJI
10658294	Not Issued	061	09/10/2003	METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	NISHIDA, SHOJI
10660509	Not Issued	161	09/12/2003	METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING	NISHIDA, SHOJI

				SOLAR CELL	
<u>10665075</u>	Not Issued	092	09/22/2003	LIQUID-PHASE GROWTH PROCESS AND LIQUID-PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>10669002</u>	6818104	150	09/24/2003	PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, PROCESS FOR PRODUCING SOLAR CELL, AND ANODIZING APPARATUS	NISHIDA, SHOJI
<u>10670301</u>	Not Issued	030	09/26/2003	METHOD FOR GROWING SILICON FILM, METHOD FOR MANUFACTURING SOLAR CELL, SEMICONDUCTOR SUBSTRATE, AND SOLAR CELL	NISHIDA, SHOJI
<u>10676094</u>	Not Issued	071	10/02/2003	LIQUID PHASE GROWTH METHOD FOR SILICON CRYSTAL, MANUFACTURING METHOD FOR SOLAR CELL AND LIQUID PHASE GROWTH APPARATUS FOR SILICON CRYSTAL	NISHIDA, SHOJI
<u>10938509</u>	Not Issued	030	09/13/2004	CONTINUOUS PRODUCTION METHOD FOR CRYSTALLINE SILICON AND PRODUCTION APPARATUS FOR THE SAME	NISHIDA, SHOJI
<u>10957577</u>	Not Issued	020	10/05/2004	ELECTRODE ARRANGING METHOD	NISHIDA, SHOJI
<u>10971130</u>	Not Issued	020	10/25/2004	PHOTOVOLTAIC DEVICE AND MANUFACTURING METHOD THEREOF	NISHIDA, SHOJI
<u>10976853</u>	Not Issued	020	11/01/2004	BASE MATERIAL OF POLYCRYSTALLINE SILICON SUBSTRATE FOR SOLAR CELL AND POLYCRYSTALLINE SILICON SUBSTRATE FOR SOLAR CELL	NISHIDA, SHOJI

Inventor Search Completed: No Records to Display.

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	Nishida	Shoji	

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Inventor Name Search Result

Your Search was:

Last Name = NISHIDA

First Name = SHOJI

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06382708</u>	4456304	150	05/27/1982	SHIELD TUNNELING MACHINE AND EARTH REMOVING APPARATUS THEREFOR	NISHIDA, SHOJI
<u>07354716</u>	5002796	150	05/22/1989	PROCESS FOR FORMING FUNCTIONAL ZINC OXIDE FILMS USING ALKYL ZINC COMPOUND AND OXYGEN-CONTAINING GAS	NISHIDA, SHOJI
<u>07355642</u>	Not Issued	166	05/23/1989	PROCESS FOR THE FORMATION OF A SILICON-CONTAINING SEMICONDUCTOR THIN FILM BY CHEMICALLY REACTING ACTIVE HYDROGEN ATOMS WITH LIQUEFIED FILM-FORMING RAW MATERIAL GAS ON THE SURFACE OF A SUBSTRATE	NISHIDA, SHOJI
<u>07425350</u>	4927786	150	10/20/1989	PROCESS FOR THE FORMATION OF A SILICON-CONTAINING SEMICONDUCTOR THIN FILM BY CHEMICALLY REACTING ACTIVE HYDROGEN ATOMS WITH LIQUEFIED FILM-FORMING RAW MATERIAL GAS ON THE SURFACE OF A SUBSTRATE	NISHIDA, SHOJI
<u>07537818</u>	5098850	150	06/14/1990	PROCESS FOR PRODUCING SUBSTRATE FOR SELECTIVE CRYSTAL GROWTH, SELECTIVE CRYSTAL GROWTH PROCESS AND PROCESS FOR PRODUCING	NISHIDA, SHOJI

				SOLAR BATTERY BY USE OF THEM	
<u>07623526</u>	<u>5103851</u>	150	12/07/1990	SOLAR BATTERY AND METHOD OF MANUFACTURING THE SAME	NISHIDA, SHOJI
<u>07794462</u>	<u>5254481</u>	150	11/19/1991	POLYCRYSTALLINE SOLAR CELL MANUFACTURING METHOD	NISHIDA, SHOJI
<u>07837976</u>	<u>5279686</u>	150	02/20/1992	SOLAR CELL AND METHOD FOR PRODUCING THE SAME	NISHIDA, SHOJI
<u>07887821</u>	<u>5269852</u>	150	05/26/1992	CRYSTALLINE SOLAR CELL AND METHOD FOR PRODUCING THE SAME	NISHIDA, SHOJI
<u>07915693</u>	Not Issued	166	07/27/1992	PROCESS FOR PRODUCING A THIN SILICON SOLAR CELL	NISHIDA, SHOJI
<u>07920497</u>	Not Issued	166	09/28/1992	PROCESS FOR PRODUCING A SOLAR CELL BY MEANS OF EPITAXIAL GROWTH PROCESS	NISHIDA, SHOJI
<u>08010627</u>	Not Issued	166	01/28/1993	A SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08190584</u>	<u>5403771</u>	150	02/02/1994	PROCESS FOR PRODUCING A SOLAR CELL BY MEANS OF EPITAXIAL GROWTH PROCESS	NISHIDA, SHOJI
<u>08262381</u>	<u>5403751</u>	150	06/20/1994	PROCESS FOR PRODUCING A THIN SILICON SOLAR CELL	NISHIDA, SHOJI
<u>08284265</u>	Not Issued	166	08/02/1994	METHOD FOR PRODUCING SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08352034</u>	<u>5575862</u>	250	11/30/1994	POLYCRYSTALLINE SILICON PHOTOELECTRIC CONVERSION DEVICE AND PROCESS FOR ITS PRODUCTION	NISHIDA, SHOJI
<u>08369325</u>	<u>5492859</u>	150	01/06/1995	METHOD FOR PRODUCING SEMICONDUCTOR DEVICE SUBSTRATE BY BONDING A POROUS LAYER AND AN AMORPHOUS LAYER	NISHIDA, SHOJI
<u>08406157</u>	<u>5584941</u>	150	03/17/1995	SOLAR CELL AND	NISHIDA, SHOJI

				PRODUCTION PROCESS THEREFOR	
<u>08932708</u>	<u>6387780</u>	150	09/18/1997	FABRICATION PROCESS OF SOLAR CELL	NISHIDA, SHOJI
<u>08993034</u>	<u>6100166</u>	150	12/18/1997	PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE	NISHIDA, SHOJI
<u>08999132</u>	<u>6190937</u>	150	12/29/1997	METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09046600</u>	<u>6258698</u>	150	03/24/1998	PROCESS FOR PRODUCING SEMICONDUCTOR SUBSTRATE	NISHIDA, SHOJI
<u>09047325</u>	<u>6211038</u>	150	03/25/1998	SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING THE SAME	NISHIDA, SHOJI
<u>09198263</u>	<u>6429035</u>	150	11/24/1998	METHOD OF GROWING SILICON CRYSTAL IN LIQUID PHASE AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09200867</u>	<u>6231667</u>	150	11/27/1998	LIQUID PHASE GROWTH METHOD AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>09208377</u>	<u>6391108</u>	150	12/10/1998	LIQUID PHASE GROWTH METHOD OF SILICON CRYSTAL, METHOD OF PRODUCING SOLAR CELL, AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>09310953</u>	<u>6248948</u>	150	05/13/1999	SOLAR CELL MODULE AND METHOD OF PRODUCING THE SAME	NISHIDA, SHOJI
<u>09310954</u>	<u>6331208</u>	150	05/13/1999	PROCESS FOR PRODUCING SOLAR CELL, PROCESS FOR PRODUCING THIN-FILM SEMICONDUCTOR, PROCESS FOR SEPARATING THIN-FILM SEMICONDUCTOR, AND PROCESS FOR FORMING SEMICONDUCTOR	NISHIDA, SHOJI
<u>09346678</u>	Not Issued	161	07/02/1999	CRYSTAL GROWTH PROCESS, SEMICONDUCTOR DEVICE, AND ITS PRODUCTION PROCESS	NISHIDA, SHOJI
<u>09401775</u>	<u>6391743</u>	150	09/22/1999	METHOD AND APPARATUS	NISHIDA, SHOJI

				FOR PRODUCING PHOTOELECTRIC CONVERSION DEVICE	
<u>09572940</u>	<u>6534336</u>	150	05/18/2000	PRODUCTION METHOD OF PHOTOELECTRIC CONVERSION DEVICE, AND PHOTOELECTRIC CONVERSION DEVICE PRODUCED BY THE METHOD	NISHIDA, SHOJI
<u>09586887</u>	<u>6664169</u>	150	06/05/2000	PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, PROCESS FOR PRODUCING SOLAR CELL, AND ANODIZING APPARATUS	NISHIDA, SHOJI
<u>09592559</u>	<u>6448155</u>	150	06/12/2000	PRODUCTION METHOD OF SEMICONDUCTOR BASE MATERIAL AND PRODUCTION METHOD OF SOLAR CELL	NISHIDA, SHOJI
<u>09634542</u>	<u>6534382</u>	150	08/08/2000	PROCESS FOR PRODUCING SEMICONDUCTOR ARTICLE	NISHIDA, SHOJI
<u>09638398</u>	<u>6756289</u>	150	08/15/2000	METHOD OF PRODUCING SEMICONDUCTOR MEMBER AND METHOD OF PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09656014</u>	<u>6682990</u>	150	09/07/2000	SEPARATION METHOD OF SEMICONDUCTOR LAYER AND PRODUCTION METHOD OF SOLAR CELL	NISHIDA, SHOJI
<u>09662604</u>	<u>6500731</u>	150	09/14/2000	PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE MODULE	NISHIDA, SHOJI
<u>09664340</u>	<u>6566277</u>	150	09/18/2000	LIQUID-PHASE GROWTH METHOD, LIQUID-PHASE GROWTH APPARATUS, AND SOLAR CELL	NISHIDA, SHOJI
<u>09764400</u>	Not Issued	161	01/19/2001	SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING THE SAME	NISHIDA, SHOJI
<u>09769329</u>	<u>6602767</u>	150	01/26/2001	METHOD FOR TRANSFERRING POROUS LAYER, METHOD FOR MAKING SEMICONDUCTOR DEVICES, AND METHOD FOR MAKING SOLAR BATTERY	NISHIDA, SHOJI

<u>09790589</u>	<u>6384313</u>	150	02/23/2001	SOLAR CELL MODULE AND METHOD OF PRODUCING THE SAME	NISHIDA, SHOJI
<u>09819680</u>	<u>6566235</u>	150	03/29/2001	PROCESS FOR PRODUCING SEMICONDUCTOR MEMBER, AND PROCESS FOR PRODUCING SOLAR CELL	NISHIDA, SHOJI
<u>09927406</u>	Not Issued	161	08/13/2001	FABRICATION PROCESS OF SOLAR CELL	NISHIDA, SHOJI
<u>09964332</u>	<u>6551908</u>	150	09/28/2001	METHOD FOR PRODUCING SEMICONDUCTOR THIN FILMS ON MOVING SUBSTRATES	NISHIDA, SHOJI
<u>09978633</u>	Not Issued	071	10/18/2001	WAFER CASSETTE, AND LIQUID-PHASE GROWTH SYSTEM AND LIQUID-PHASE GROWTH PROCESS WHICH MAKE USE OF THE SAME	NISHIDA, SHOJI
<u>10014418</u>	Not Issued	071	12/14/2001	LIQUID PHASE GROWTH PROCESS, LIQUID PHASE GROWTH SYSTEM AND SUBSTRATE MEMBER PRODUCTION METHOD	NISHIDA, SHOJI
<u>10022545</u>	<u>6802900</u>	150	12/20/2001	LIQUID PHASE GROWTH METHODS AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>10083585</u>	<u>6720237</u>	150	02/27/2002	METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	NISHIDA, SHOJI
<u>10120357</u>	Not Issued	161	04/12/2002	LIQUID PHASE GROWTH METHOD OF SILICON CRYSTAL, METHOD OF PRODUCING SOLAR, CELL, AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI
<u>10229123</u>	<u>6824609</u>	150	08/28/2002	LIQUID PHASE GROWTH METHOD AND LIQUID PHASE GROWTH APPARATUS	NISHIDA, SHOJI

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